

INFORMATION DISCLOSURE CITATION

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ATTY DOCKET NO.

WLJ.068D

SERIAL NO.

NEW

John MACNEIL

FILING

August 12, 2003

GROUP

To Be Assigned

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
AC	A	3,223,040	12/14/1965	DINKELKAMP			
	B	4,793,524	12/27/1998	STARR			
	C	5,095,938	03/17/1992	GARRISON			
	D	5,098,741	03/24/1992	NOLET ET AL.			
	E	5,195,655	03/23/1993	BUKHMAN			
	F	5,356,034	10/18/1994	SCHLUMBERGER			
	G	5,534,069	07/09/1996	KUWABARA ET AL.			
	H	5,620,524	04/15/1997	FAN ET AL.			
	I	5,730,804	03/24/1998	GOMI ET AL.			
	J	5,876,503	03/02/1999	ROEDER ET AL.			
AC	K	5,273,851	12/28/1993	TAKEI ET AL.			

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
AC	L	GB 2 108 133 A	05/11/1983	UNITED KINGDOM				
	M	GB 2 280 169 A	01/25/1995	UNITED KINGDOM				
	N	GB 2 111 064 A	06/29/1983	UNITED KINGDOM				
	O	EP 0 826 791 A2	03/04/1998	EPO				
AC	P	EP 0 212 691 A1	03/04/1987	EPO				

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

AC	Q	EPO, PATENT ABSTRACTS OF JAPAN, PUBLICATION NO. 10310866, PUBLICATION DATE 24-11-98, Kamiya Kazuo
AC	R	A. Grill et al., "Low dielectric constant films prepared by plasma-enhanced chemical vapor deposition from tetramethylsilane, "Journal of Applied Physics, Volume 85, Number 6, 15 March 1999, pages 3314-3318.

EXAMINER

DATE CONSIDERED

4/28/04

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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Ac	S	5,273,851	12/28/1993	TAKAE ET AL.			
	T	5,314,724	05/24/1994	TSUKUNE ET AL.			
	U	5,494,712	02/27/1996	HU ET AL.			
	V	5,593,741	01/14/1997	IKEDA			
	W	5,641,559	06/24/1997	NAMIKI			
	X	5,786,039	07/28/1998	BROUQUET			
	Y	4,096,315	06/20/1978	KUBACKI			
	Z	4,822,632	04/18/1989	WILLIAMS ET AL.			
	AA	4,894,254	01/16/1990	NAKAYAMA ET AL.			
Ac	BB	5,270,267	12/14/1993	OUELLET			

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
Ac	CC	EP 0 726 599 A2	08/14/1996	EPO				
	DD	EP 0 529 334 A2	03/03/1993	EPO				
	EE	G 2 220 869 A	01/24/1990	UNITED KINGDOM				
	FF	EP 0 254 205 A2	01/27/1998	EPO				
Ac	GG	WO 96/29576	09/26/1996	PCT				

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

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